



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
PTO-1449

Sheet 1 of 2

Application No.: 10/516,811
Filing Date: December 6, 2004
First Named Inventor: Richard SYMS
Art Unit: Unassigned 2874
Examiner Name: Unassigned
Attorney Docket Number: 3599 P 007

U.S. PATENT DOCUMENTS

Examiner Initial	Document No. Kind Code (if known)	Name of Patentee or Applicant	Issue Date (MM-DD-YYYY)
JD	US 4,311,999	Upton et al.	01-19-1982
	US 4,317,611	Petersen	03-02-1982
	US 5,097,354	Goto	03-17-1992
	US 5,404,001	Bard et al.	04-04-1995
	US 5,422,469	Bard et al.	06-06-1995
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FOREIGN PATENT DOCUMENTS

Examiner Initial	Foreign Patent Document			Name of Patentee or Applicant	Date of Publication	T
	Office	Number	Kind			
JD	EPO	EP 0 875 780	A2	Rockwell International Corp.	04-11-1998	

OTHER PRIOR ART OR NON-PATENT LITERATURE DOCUMENTS

Examiner Initial	(including Author (in capital letters), Title of the article, Title of the item, Date, Pages, Volume-Issue number, Publisher, City and/or Country where published.)	T
JD	ROBERTS, DAVID A. and SYMS, RICHARD R.A., "1D and 2D laser line scan generation using a fibre optic resonant scanner," Micro-Opto-Electro-Mechanical Systems, Glasgow, UK. 22-23, May (2000).	

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JD	"Dual numerical aperture confocal operation of moving fibre bar code reader" ELECTRONICS LETTERS, Vol. 35, No. 19, pp. 1656-1658, (1999).	
JD	SYMS, R R A, <i>Long-travel electrothermally driven resonant cantilever microactuators</i> ," Journal of Micromechanics and Microengineering, Vol. 12, pp. 211-218, (2002).	
JD	"Operation of surface-tension self-assembled 3D micro-optomechanical torsion mirror scanner" "ELECTRONICS LETTERS, Vol. 35, No. 14, pp. 1157-1158, (1999).	
JD	GERLACH, Torsten et al., "Automatic adjustment of monomode optical waveguides by a microsystem," J. Micromech. Microeng. Vol. 7, pp. 227-229, (1997).	
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JD	KAN, S.C. et al., "Silicon-on-insulator (SOI) movable integrated optical waveguide technology," Sensors and Actuators – A Physical, Vol. 54, no. 1-3, pp. 679-683, (1996).	

Examiner Signature: Jennifer Doan

Date Considered: 03/03/06

Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.